

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Jong-Kill Lim
Serial No.: 10/021,608
Filing Date: December 11, 2001
Title: EXPOSURE CONTROL APPARATUS IN A LITHOGRAPHY SYSTEM AND METHOD THEREOF

Examiner: Not yet known
Group Art Unit: 2812

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Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- ☒ under 37 CFR 1.97 (b), or
(Within three months of filing national application; or date of entry of International application; or before mailing date of first office action on the merits; whichever occurs last)
- ☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

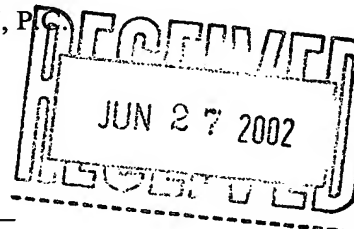


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PATENT TRADEMARK OFFICE

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